

OK to enter
137
10114/05

Attorney Docket No.: 0180181

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Bell, et al.

Serial No.: 10/656,467

Filed: 09/05/2003

For: Method for Reducing Resist Height
Erosion in a Gate Etch Process

Art Unit: 1765

Examiner: Tran, Binh X.

RECEIVED
CENTRAL FAX CENTER
OCT 11 2005

AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir/Madam:

This is in response to the *Final* Office Action dated September 6, 2005 in the above-referenced patent application. Please enter and consider the following amendments and remarks.